

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Hiroshi, et al.  
Appl. No.: 10/563,630  
Conf. No.: 1962  
Filed: March 6, 2006  
Title: NITRIDE SEMICONDUCTOR DEVICE AND METHOD FOR  
PREPARATION THEREOF  
Art Unit: 2818  
Examiner: David J. Goodwin  
Docket No.: 118075-002

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO NON-FINAL OFFICE ACTION**

Sir:

In response to the Office Action dated September 28, 2006, please amend the above-identified patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.